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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
UNJI KAWASAKI	Examiner: NYA
Application No.: 10/086,562	Group Art Unit: 2879
Filed: March 4, 2002	:)
For: METHOD OF FABRICATING ELECTRON SOURCE SUBSTRAT AND IMAGE FORMING APPARATUS	:) ΓΕ :) : July 17, 2002

Commissioner for Patents Washington, D.C. 20231

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the document listed on the enclosed Form PTO-1449. A copy of the listed document is also enclosed.

The Examiner's attention is also directed to the following U.S. Application:

APPLICATION NO.	FILING DATE	GROUP ART UNIT
09/788,411	2/21/01	2812

A copy of the cited Application is enclosed.

For the concise explanation of relevance for the Japanese document listed on the enclosed Form PTO-1449, the Examiner is respectfully referred to Application No. 09/788,411, which is an English-language counterpart of that Japanese document.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicant's undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

Attorney for Applicant

Registration No. 42476

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza
New York, New York 10112-3801
275725v1

FORM PTO 1449 (mod	dified)	PE	ATTY DOCKET NO.	APPLICATION NO.		
U.S. D PATEN	PEPARTMENT OF COMMERCE IT AND TRADEMARK OFFICE	ي م	03500.016245.		10/086,562	
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	5,622,634	4/97	Noma et al.	216	40	
	6,169,356 B1	1/01	Ohnishi et al.	313	495	
			FOREIGN PATENT DOCUMENTS			
						TRANSLATION
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	YES/NO/ OR ABSTRACT
	8-171849	7/96	Japan			Abstract
	7-235255	9/95	Japan			Abstract
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^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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	Commissioner for Patents Washington, D.C. 20231 Date 7 02 02 Mo. Day Yr. Application for Obj 562
FCHS-D-00	Sir: Kindly acknowledge receipt of the accompanying: Response to Official Action. Check for \$